

FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
ASMMC.036AUSAPPLICATION NO.
09/975,466INFORMATION DISCLOSURE STATEMENT
BY APPLICANT

(USE SEVERAL SHEETS IF NECESSARY)

APPLICANT
Sophie et al.FILING DATE
October 9, 2001GROUP
2813EXAMINER
INITIAL

OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

EK

1.

Yagishita et al., "Cleaning of Copper Surface Using Vapor-Phase Organic Acids," Materials Researching Society Spring 2003 Meeting, Symposium E, Session E, Paper E3.28

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JUL 29 2003
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EXAMINER

Eric Kish

DATE CONSIDERED

12/13/03

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